

IFW



PATENT
8015-1023

IN THE U.S. PATENT AND TRADEMARK OFFICE

In re application of

Takeshi KONNO

Conf. 9732

Application No. 10/682,540

Group 1762

Filed October 10, 2003

Examiner W. Fletcher, III

ANTISTATIC FILM MANUFACTURING METHOD

AMENDMENT

Assistant Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

July 17, 2007

Sir:

In response to the Official Action mailed April 17, 2007, please amend the above-identified application as follows:

Amendments to the Specification begin on page 2 of this paper.

Amendments to the Claims are reflected in the listing of claims which begins on page 3 of this paper.

Amendments to the Drawings begin on page 11 of this paper.

Remarks begin on page 12 of this paper.

An **Appendix** is attached following the signature page of this paper.